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Applicant:  
Liu et al.

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## U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
PD	5,363,697	11/15/1994	Nakagawa	—	—	
↑	5,372,930	12/13/1994	Colton et al.	—	—	
	5,666,190	09/09/1987	Quate et al.	—	—	
	5,696,491	12/09/1997	White et al.	—	—	
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	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	WO 00/41213	07/13/2000	PCT				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

PD	Seunghun Hong, C.A. Mirkin, "A nanoplotter with both parallel and serial writing capabilities", Science, Vol. 288, No. 5472, pp. 1808-11, June 9, 2000.
↑	Jin Zhu, "Chemical and physical methods for the modification of high-temperature superconductors, nanoparticles and other inorganic substrates (Abstract)", The Sciences and Engineering, Vol. 60-12B, pp.6102, 1999.
	Dana A. Weinberger, Seunghun Hong, Chad A. Mirkin, B.W. Wessels, Thomas B. Higgins, "Combinatorial generation and analysis of nanometer-and micrometer-scale silicon features via 'dip-pen' nanolithography and wet chemical etching", Advanced Materials, Vol. 12, No. 21, pp. 1600-1603, November 2000.
	R.D. Piner, Jin Zhu, Feng Xu, Seunghun Hong, C.A. Mirkin, "'Dip-Pen' nanolithography", Science, Vol. 283, No. 5402, pp. 661-3, January 29, 1999.
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✓	Michael Gross, "Incredible nanoplotter", Chemistry in Britain, Vol. 36, No. 10, p. 25, October 2000.
PD	S. Hong, J. Zhu, C.A. Mirkin, "Multiple ink nanolithography: toward a multiple-pen nano-plotter", Science, Vol. 286, No. 5439, pp. 523-5, Oct. 15, 1999.

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